IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuo NAITO et al.

Application No.: 10/569,512

Filed: February 27, 2006 Docket No.: 127198

For: ELECTROMAGNETIC WAVE SHIELDING FILM FOR PLASMA DISPLAY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- Relevance of one or more non-English language reference is discussed in the present specification. See References 9-14.
- One or more reference cited herein was cited in the International Search Report.
 An English language version of the International Search Report is attached for the Examiner's information. See References 1-8.
- 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 5. An English language Abstract of one or more non-English language reference is attached hereto. See References 3-14.
- 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 3-14.

Respectfully submitted,

Registration No. 27,075

Randi B. Isaacs Registration No. 56,046

JAO:RBI/yxm Date: April 3, 2006 OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry:

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Form PTO-1449 US Dept. of Cor (REV. 1/06) PATENT & TRADEMARK C INFORMATION DISCLOSURE STATEMENT			ATTY DOCKET NO. 127198			APPLICATION NO. 10/569,512					
(Use several sheets if necessary)				APPLICANTS Nobuo NAITO et al.							
				FILING DATE							
February 27, 2006											
U.S. PATENT DOCUMENTS Examiner Cite											
Initials	No.	Document Number	Da	te	Name						
	1	US 2003/0094296 A1	05/22/20	03	Kojima et al.						
	2	US 2003/0007341 A1	01/09/20	03	Shimamura et al.						
		FORE	IGN PATI	NT DOC	UMENTS						
Examiner Initials	Cite No.	Document Number Da		te	Country		With English Abstract	With English Translation			
	3	JP A 2003-086991	03/20/20	03	JAPAN		x	х			
	4	JP A 2003-005663	01/08/20	03	JAPAN		х	х			
	5	JP A 2000-265087	09/26/20	00	JAPAN		х	х			
	6	JP A 2001-053488 02/23/20		01	JAPAN		х	х			
	8	JP A 2003-023290 01/2		03 JAPAN			х	х			
	9	JP A 2003-015533 01/17		03	3 JAPAN		х	х			
	10	JP A 2003-066854	03/05/2003		JAPAN		x	х			
	11	JP A 2000-324431	11/08/2002		JAPAN		х	х			
	12	JP A 2000-235115 08		00	JAPAN		х	х			
	13	JP A 2000-137442 05/		6/2000 JAPAN			х	х			
	14	JP A 10-186127 07/14/19		98	JAPAN		х	х			
			OTHER D	OCUME	NTS						
Examiner Initials	Cite (Including Author, Title, Date, Pertinent Pages, etc.) No.										
EXAMINER /William P WatkinsIII/ DATES 105/261850											
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											